

This 1449 belongs to the FDS 2-19-04.

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U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)				ATTY. DOCKET NO.		APPLICATION NO.	
				FELD-132XX		10782012	
				APPLICANT: Anne-Claire Pliska, et al.			
				FILING DATE		TC ART UNIT	
				Herewith			
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL	DOCUMENT NUMBER	PUBLICATION/ ISSUE DATE	NAME	CLASS	SUBCLASS	FILING DATE	
	US 6,280,100	8/28/2001	Haake				
	US 6,456,751	9/24/2002	Helkey, et al.				
	US 5,881,198	3/9/1999	Haake				
	US 2002/110,328	8/15/2002	Bischel, et al.				
	US						
	US						
	US						
FOREIGN PATENT DOCUMENTS							
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, etc.)							
	* ENIKOV, E.T., et al.: "Three-dimensional microfabrication for a multi-degree-of-freedom capacitive force sensor using fibre-chip coupling," JOURNAL OF MICROMECHANICS AND MICROENGINEERING, December 2000, IOP Publishing, UK, vol. 10, no. 4, pages 492-497.						
EXAMINER				DATE CONSIDERED			
*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							
LG/mc/302119-1							

Article reference is enclosed